

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10552984			
<b>Filing Date:</b>	25-Sep-2006			
<b>Title of Invention:</b>	Test structure for electrically verifying the depths of trench-etching in an soi wafer, and associated working methods			
<b>First Named Inventor/Applicant Name:</b>	Ralf Lerner			
<b>Filer:</b>	James L. Rowland/Christopher Rosenthal			
<b>Attorney Docket Number:</b>	P28504			
Filed as Large Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
Claims in excess of 20	1615	7	52	364
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 3 months with \$0 paid	1253	1	1110	1110
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>1474</b>